IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

the Application of

Satoshi TAKANO

Group Art Unit: 2825

Application No.: 09/819,690

Examiner:

G. Lee

Filed:

March 29, 2001

Docket No.: 109107

For:

SEMICONDUCTOR MANUFACTURING METHOD, SUBSTRATE PROCESSING '

METHOD, AND SEMICONDUCTOR MANUFACTURING APPARATUS

NOTICE OF APPEAL TO THE BOARD OF PATENT APPEALS AND INTERFERENCES AND PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the Decision of the Primary Examiner dated June 3, 2003.

The \$330.00 Appeal Fee (\$165.00 Small Entity) is:

X	Enclosed (our Check No. 148886)
	Not required (fee paid in prior appeal in this application with no Board Decision on the merits).

The shortened statutory period having expired September 3, 2003, it is hereby requested that the period for response be extended for 3 months. Also attached is a check in the amount of \$840.00 in payment of the fee for a three month extension of time for filing this Notice of Appeal. Payment of \$110.00 the first one-month extension of time was paid on October 3, 2003 with check no. 147076.

The Commissioner is hereby authorized to charge any fees which may be required or credit any overpayment to Deposit Account No. 15-0461. Two duplicate copies of this document are enclosed.

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330.00 OP 840.00 OP

Respectfully submitted,

James A. Oliff Registration No. 27,075

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JAO:PDM/ccs

Date: December 3, 2003

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DEPOSIT ACCOUNT USE AUTHORIZATION

Please grant any extension necessary for entry; Charge any fee due to our

Deposit Account No. 15-0461